

# FINAL PRODUCT/PROCESS CHANGE NOTIFICATION # 16790FK

Generic Copy

Issue Date: 04-Aug-2014

**TITLE:** Final PCN for wafer fab transfer from Gunma and Gifu in Japan to ON Semiconductor Niigata Co., Ltd. in Niigata, Japan (Group FK).

**PROPOSED FIRST SHIP DATE**: 12-Nov-2014 (the actual ship date will be different by each product, please check with the responsible Sales person).

AFFECTED CHANGE CATEGORY(S): Wafer Fabrication Location Change

## **FOR ANY QUESTIONS CONCERNING THIS NOTIFICATION:**

Contact your local ON Semiconductor Sales Office or Yasuhiro.lgarashi@onsemi.com

**SAMPLES:** Contact your local ON Semiconductor Sales Office or <a href="mailto:Shigehito.Matsumoto@onsemi.com">Shigehito.Matsumoto@onsemi.com</a>

**ADDITIONAL RELIABILITY DATA:** May be available

Contact your local ON Semiconductor Sales Office or Kazutoshi.Kitazume@onsemi.com

#### **NOTIFICATION TYPE:**

Final Product/Process Change Notification (FPCN)

Final change notification sent to customers. FPCNs are issued at least 97 days prior to implementation of the change.

ON Semiconductor will consider this change approved unless specific conditions of acceptance are provided in writing within 30 days of receipt of this notice. To do so, contact <quality@onsemi.com>

#### **DESCRIPTION AND PURPOSE:**

This is a Final Process Change Notification to announce the transfer of products from ON Semiconductor wafer fabrication sites located in Gunma and Gifu to ON Semiconductor Niigata Co., Ltd. (OSNC). OSNC is located in Niigata, Japan.

The product design and electrical specifications will remain identical. A full electrical characterization over the temperature range will be performed for each product to check the device functionality and electrical specifications. Qualification tests are designed to show that the reliability of transferred devices will continue to meet or exceed ON Semiconductor standards.

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### **RELIABILITY DATA SUMMARY**

# **Group FK**

Conditions:	Interval:	Results
Tj=150degC	1000 hrs	Pass
Ta=150degC,VDSS=max	1000 hrs	Pass
Ta=85degC, RH=85%	1000 hrs	Pass
Ta=-55degC to 150degC 30min	100 cycles	Pass
Ta=121degC,2.03×10⁵Pa,100%	50 hrs	Pass
Ta=150degC	1000 hrs	Pass
Ta=-55degC	1000 hrs	Pass
ow) Solder Temp.:260degC±5degC	10s	Pass
Solder Temp.: 245degC±5degC	5s	Pass
	Tj=150degC Ta=150degC,VDSS=max Ta=85degC, RH=85% Ta=-55degC to 150degC 30min Ta=121degC,2.03×10 <sup>5</sup> Pa,100% Ta=150degC Ta=-55degC ow) Solder Temp.:260degC±5degC	Tj=150degC       1000 hrs         Ta=150degC,VDSS=max       1000 hrs         Ta=85degC, RH=85%       1000 hrs         Ta=-55degC to 150degC 30min       100 cycles         Ta=121degC,2.03×10⁵Pa,100%       50 hrs         Ta=150degC       1000 hrs         Ta=-55degC       1000 hrs         ow)       Solder Temp.:260degC±5degC       10s

# **ELECTRICAL CHARACTERISTIC SUMMARY**

There is no change in electrical parametric performance. Characterization data is available upon request.

# **CHANGED PART IDENTIFICATION**

No change to current part marking will occur. Marking traceability codes will be able to identify wafer fab die source.

# **List of affected General parts:**

**Group FK** 

PART\_ID SCH1331-TL-H

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